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Application Number	09/827,971
Filing Date	April 6, 2001
First Named Inventor	Jason Soulogiou
Group Art Unit	2122
Examiner Name	To Be Assigned Chih-Ching Chow
Attorney Docket Number	032091.0003.CIP1

U.S. PATENT DOCUMENTS						
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CC		AHO, et al., "Chapter 9: Code Generation," <i>Compilers- Principles, Techniques, and Tools</i> , 522-584 (1986)			
		AHO, et al., "Chapter 10: Code Optimization," <i>Compilers- Principles, Techniques, and Tools</i> , 603-722 (1986)			
		WITCHEL, et al., "Embra: Fast and Flexible Machine Simulation," <i>Sigmetrics</i> , 68-79 (1996)			

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Examiner Signature	Chih-Ching Chow	Date Considered	2/3/06
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